



501.39932CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: J. Noguchi et al.

Serial No.: 10/811,927

Filed: March 30, 2004

For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE AND
FABRICATION METHOD FOR SEMICONDUCTOR INTEGRATED
CIRCUIT DEVICE

Art Unit: 10/811,927

Examiner: Au, Bac

AMENDMENT

Mail Stop: Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 12, 2006

Sir:

This is in response to the Office Action mailed March 10, 2006, in connection with the above-identified application. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.